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CONFIRMATION NO. 7189

SERIAL NUMBER 10/519,837	FILING OR 371(c) DATE 07/05/2005 RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. 264197US0PCT
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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP03/08333 06/30/2003

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2002-208515 07/17/2002

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	<u> </u> Examiner's Signature <u> </u> Initials				

**ADDRESS**

22850

**TITLE**

High-resistance silicon wafer and process for producing the same

FILING FEE RECEIVED 1230	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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